



501.36931CX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: IWASAKI, et al  
Serial No.: 09/985,904  
Filed: November 6, 2001  
For: SEMICONDUCTOR DEVICE HAVNG LAYERED  
INTERCONNECT STRUCTRE WITH A COPPER OR PLATINUM  
CONDUCTING FILM AND A NEIGHBORING FILM (As Amended)  
Group: 2813  
Examiner: Stephen W. Smoot

2813\$  
#4/Ex  
9/26/2  
Smoot

PETITION FOR EXTENSION OF TIME

Assistant Commissioner of Patents  
Washington, D.C. 20231

September 20, 2002

Sir:

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a response within the **third** month subsequent to expiration of the shortened statutory period set in the outstanding Office Action dated March 20, 2002. (A Credit Card Authorization form is attached to cover the required fee of Applicants)

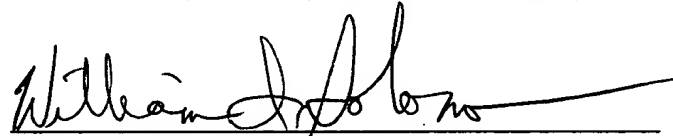
It is requested that any shortage of fees due in connection with the filing of this paper, including extension of time fees, be charged to Deposit Account No. 01-2135 (reference 501.36931CX1), and please credit any excess fees to such deposit account.

Respectfully submitted,  
ANTONELLI, TERRY, STOUT & KRAUS, LLP

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920.00 DP

  
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